Supporting Information

Influence of Fluorine Substituents on the Film Dielectric Constant and Open-circuit Voltage in Organic Photovoltaics

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Figure S1 Optimized structures and calculated frontier orbitals for P0F, P1F and P2F.



Figure S2 Photoelectron spectroscopy in air of **P0F**, **P1F** and **P2F** films (the dash lines were added to help visualize the curve onsets, HOMO_{P0F}=-5.23 eV, HOMO_{P1F}=-5.30 eV and HOMO_{P2F}=-5.31 eV).

Dark Current Density and Modified Shockley Equation Fitting



Figure S3 *J-V* characteristics of ITO/PEDOT:PSS/polymer: $PC_{61}BM/Ca/Al$ under dark (Scatter) and simulation (Dot dash line) fitted according to the modified Shockley equation.

The ideality factor (*n*) and reverse saturation current density (J_0) were obtained by fitting the *J-V* characteristics of each device under dark with the modified Shockley equation:^{1,2}

$$J_{dark}(V) = J_0 \left\{ \exp\left[\frac{e(V - J_{dark}(V)r_s)}{nk_BT}\right] - 1 \right\}$$
(1)

where J_{dark} is the dark current density, J_0 is the reverse-bias saturation current density, e the elemental electron charge, $r_s = R_s \cdot \text{area of device the specific series resistance, } n$ the ideality

factor, k_B is the Boltzmann's constant and *T* the temperature. Furthermore, with *n* and J_0 obtained from fitting, V_{oc} of each device can be determined by:^{2,3}

$$V_{OC} = \frac{nk_BT}{e} \ln\left[\frac{-J_{ph}(V_{OC})}{J_0} + 1\right] \approx \frac{nk_BT}{e} \ln\left(\frac{J_{SC}}{J_C} + 1\right)$$

(2)

Table S1 below summarizes the fitting results of important parameters.

Table S1 Parameters of device obtained by fitting *J-V* characteristics under dark with modified Shockley equation

	$L(m \Lambda/am^2)$	n	J_{sc} $R_{sh}(k\Omega)$		V_{oc} (V)	
	J_0 (IIIA/CIII)		(mA/cm^2)		Simulated	measured
P0F:PCBM	3.74×10 ⁻¹³	1.54	6.37	20±4	0.835	0.832
P1F:PCBM	2.30×10 ⁻¹³	1.58	6.52	19±3	0.878	0.872
P2F:PCBM	4.03×10 ⁻¹⁴	1.51	6.84	22±3	0.912	0.914



Figure S4 Capacitance measurement of (a) P0F, (b) P1F and (c) P2F pure and blends film on 300 nm SiO_2 layer.

Reference:

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- 3. X. Tong, B. E. Lassiter, and S. R. Forrest, Org. Electron., 2010, 11, 705.